

00684.003654

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: J. G. Jelsma
Takako YAMAGUCHI et al.	)	
	:	Group Art Unit: 1795
Application No.: 10/529,891	)	
	:	Confirmation No.: 7802
Completion of Entry into U.S. National	)	
Stage Under 35 U.S.C. § 371(c): July 26, 2005	:	
	)	
For: EXPOSURE MASK, METHOD OF DESIGNING:		
AND MANUFACTURING THE SAME,	)	
EXPOSURE METHOD AND APPARATUS,	:	
PATTERN FORMING METHOD, AND DEVICE)		
MANUFACTURING METHOD	:	November 3, 2009

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated August 3, 2009, please amend the above-identified application as follows: